

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: OHTO et al.
FILED: December 30, 2003
FOR: ORGANIC INSULATING FILM, MANUFACTURING METHOD
THEREOF, SEMICONDUCTOR DEVICE USING SUCH ORGANIC
INSULATING FILM AND MANUFACTURING METHOD THEREOF
DOCKET: NEC NE03P181

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicants hereby attach U.S. Patent Office Form PTO-1449, including copies of the references listed therein, which were considered prior to the initial filing. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitutes prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,



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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

NEC NE03P181

Application Number

Applicant(s)

OHTO et al.

Filing Date

December 30, 2003

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2001-127159	11.05.2001	JAPAN (w/Abstract)	H01L	21/768		✓
		2002-083870	22.03.2002	JAPAN (w/Abstract)	H01L	21/768		✓
		2002-275631	25.09.2002	JAPAN (w/Abstract)	C23C	16/42		✓
		WO 99/41423	19.08.1999	WIPO	C23C	A2		✓
		WO 00/19498	06.04.2000	WIPO	H01L	21/027		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and no considered. Include copy of this form with next communication to applicant.